

Solutions: Session 10

Exercise 1

Answers:

- 1) In the diagram representing the pressure insole (Fig. 2), we can see 3 different plates that effectively function as two capacitors. When plate 1 is displaced, it brings about a change in the area "seen" by the other capacitors. We already saw in the course that this double-capacitor system can be conditioned with the circuit below (Fig. 3).

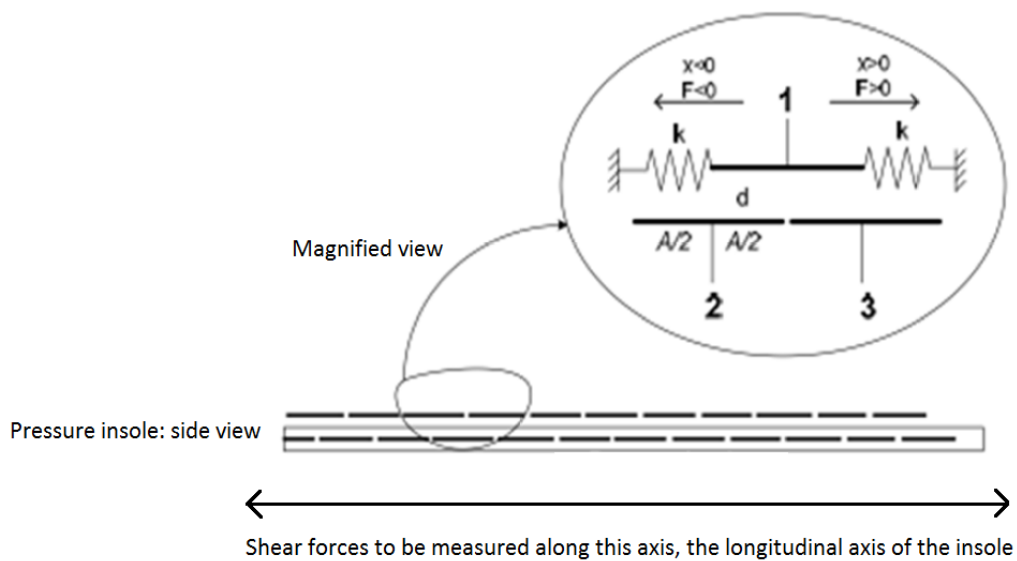


Figure 2: representation of the pressure insole

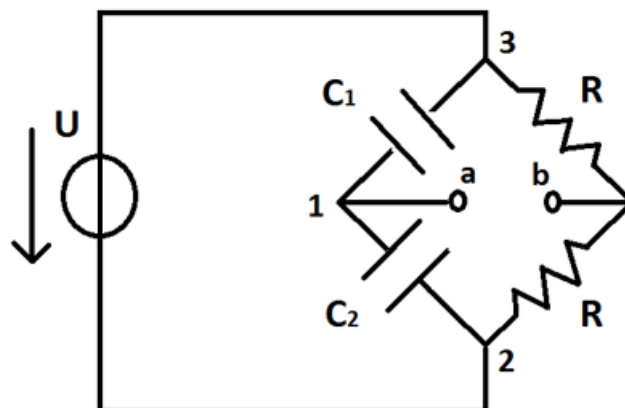


Figure 3: Conditioning bridge

Note that plate 1 in Fig. 2 has been represented as two plates in Fig. 3 for clarity.

- 2) Let us start by analysing what happens when the insole experiences a shear force F along its longitudinal axis. The effect of this force on the two springs attached to plate 1 in Fig. 1 is shown in Fig. 4 below (where the plate, being a rigid object, has been removed for clarity).

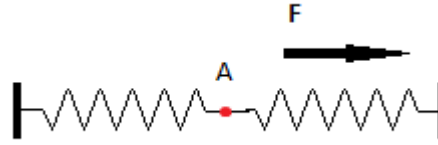


Figure 4: Springs in series

When we apply a force F on point A, we will get a displacement:

$$\begin{aligned} F_{k1} + F_{k2} &= F \\ k_1 x_1 + k_2 x_2 &= F \\ \text{Given that } k_1 &= k_2 = k \\ \therefore x_1 = x_2 = x &= \frac{F}{2k} \end{aligned}$$

This will enable us to get the capacitance of each sensor. Let us recall the definition of capacitance:

$$\text{Capacitance} = C = \epsilon \frac{\text{Surface area common to both plates}}{\text{Distance between plates}}$$

Here, $\epsilon = \epsilon_r \epsilon_0$, with ϵ_0 being the permittivity of vacuum. Let the side length of each square-shaped capacitor be a . Thus, $A = a \times a$. Let plate 1 be displaced to the left (refer Fig. 2) by an amount $x = \frac{F}{2k}$. Then, due to a change in the surface area of plate 1 “seen” by the plates 3 and 2, the capacitance values C_1 (formed by plates 1 and 3) and C_2 (formed by plates 1 and 2) will change in the following way:

$$\begin{aligned} C_1 &= \epsilon * \frac{a * \left(\frac{a}{2} - x\right)}{d} = \epsilon \frac{a^2}{2d} - \frac{\epsilon a F}{2dk} \\ C_2 &= \epsilon * \frac{a * \left(\frac{a}{2} + x\right)}{d} = \epsilon \frac{a^2}{2d} + \frac{\epsilon a F}{2dk} \end{aligned}$$

We can then obtain the measured voltage, U_0 from Fig. 3 as:

$$\begin{aligned} U_0 &= U_a - U_b \\ U_a &= \frac{\frac{1}{j\omega C_2}}{\frac{1}{j\omega C_1} + \frac{1}{j\omega C_2}} U = \frac{\frac{1}{C_2}}{\frac{C_2 + C_1}{C_2 C_1}} U \\ U_b &= \frac{R}{R + R} U = \frac{1}{2} U \\ U_0 &= \left(\frac{\frac{1}{C_2}}{\frac{C_2 + C_1}{C_2 C_1}} - \frac{1}{2} \right) U \end{aligned}$$

$$U_0 = \frac{1}{2} * \frac{C_1 - C_2}{C_2 + C_1} U$$

$$U_0 = -\frac{1}{2} * \frac{\frac{\epsilon a F}{dk}}{\frac{\epsilon a^2}{d}} U = -\frac{FU}{2ka}$$

The sensitivity in terms of the supply voltage U can then be written as:

$$S' = \frac{U_0}{F} = -\frac{U}{2ka}$$

Expressed in units of $V/V_{supply}/N$, the sensitivity S becomes:

$$S = \frac{S'}{U} = -\frac{1}{2ka} = -5 \text{ mV}/V_{supply}/N$$

Exercise 2

Answers

a) When $\Delta P = 0$, both capacitors have the same capacitance, given by:

$$C_o = \frac{A\epsilon}{x_o}$$

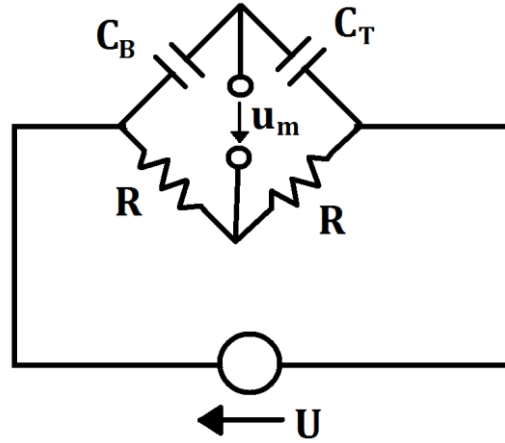
Consider that the mobile frame is displaced upwards by Δx so that the distance between the top fixed plate and the central movable plate reduces to $x_o - \Delta x$. The capacitance C_T between the top fixed plate and the central movable plate becomes:

$$C_T = \frac{A\epsilon}{x_o - \Delta x} = \frac{A\epsilon(x_o + \Delta x)}{(x_o - \Delta x)(x_o + \Delta x)} = \frac{A\epsilon}{x_o} \left(1 + \frac{\Delta x}{x_o}\right) = C_o \left(1 + \frac{\Delta x}{x_o}\right)$$

At the same time, this means that the distance between the bottom fixed plate and the central movable plate increases to $x_o + \Delta x$. Thus, the capacitance C_B between the bottom fixed plate and the central movable plate becomes:

$$C_B = \frac{A\epsilon}{x_o + \Delta x} = \frac{A\epsilon(x_o - \Delta x)}{(x_o + \Delta x)(x_o - \Delta x)} = \frac{A\epsilon}{x_o} \left(1 - \frac{\Delta x}{x_o}\right) = C_o \left(1 - \frac{\Delta x}{x_o}\right)$$

b) The scenario described in part (a) above can be represented schematically as shown in the figure below:



From this, we can write an expression for u_m as follows:

$$u_m = u \left(\frac{C_T}{C_T + C_B} - \frac{R}{2R} \right) = u \left(\frac{C_o \left(1 + \frac{\Delta x}{x_o} \right)}{C_o \left(1 + \frac{\Delta x}{x_o} + 1 - \frac{\Delta x}{x_o} \right)} - \frac{1}{2} \right) = \frac{u \Delta x}{2x_o} = \frac{u \Delta P}{4x_o} = \frac{uQ}{40x_o}$$

From this, we find the sensitivity S to be:

$$S = \frac{u_m}{uQ} = \frac{1}{40x_o} = 2.5 \text{ V}_{\text{rms}} / (\text{V}_{\text{rms}} \cdot \text{m}^3/\text{s})$$

- c) From the expression found for u_m in part (b), we obtain an expression for Q and calculate it when $u_m = 10 \text{ mV}_{\text{rms}}$ as follows:

$$Q = \frac{40u_mx_o}{u} = \frac{40 \times 10^{-2} \times 10^{-2}}{1} = 4 \times 10^{-3} \text{ m}^3/\text{s}$$

From the flow rate, we may calculate the mean cross-sectional velocity in the tube v_m as:

$$v_m = \frac{4Q}{\pi D^2}$$

where D is the diameter of the tube given to be 20 mm.

To check whether flow is laminar or not, we need to compute the Reynolds number, which is given by:

$$Nr = \frac{\rho_{\text{air}} v_m D}{\eta_{\text{air}}} = \frac{\left(\rho_{\text{air}} \times \frac{4Q}{\pi D^2} \times D \right)}{\eta_{\text{air}}} = \frac{4\rho_{\text{air}} Q}{\pi \eta_{\text{air}} D} = \mathbf{17234}$$

The criterion for flow to be laminar is $Nr < 2000$. Since $Nr = 17234$ in our case, the flow is **not laminar**.

Exercise 3

The total amount of inert gas is the same at the beginning and end of the measurement, but its concentration has changed from $C_1=10\%$ to $C_2=3.7\%$. At the beginning, it is confined to the inspired volume (V_1) measured by pneumotachometer and at the end to the patient's TLC:

$$C_1 \cdot V_1 = C_2 \cdot TLC$$

$$V_1 = 10 \text{ s} \times 0.2 \text{ l/s} = 2 \text{ l}$$

$$TLC = 2 \text{ l} \times \left(\frac{10 \%}{3.7 \%} \right) = 5.4 \text{ l}$$